Hyvönen, N.; Kaarnioja, V.; Mustonen, L.; Staboulis, S.

**Polynomial collocation for handling an inaccurately known measurement configuration in electrical impedance tomography**

*Published in:*
SIAM Journal on Applied Mathematics

*DOI:*
10.1137/16M1068888

Published: 01/01/2017

*Document Version*
Publisher's PDF, also known as Version of record

*Please cite the original version:*
POLYNOMIAL COLLOCATION FOR HANDLING AN INACCURATELY KNOWN MEASUREMENT CONFIGURATION IN ELECTRICAL IMPEDANCE TOMOGRAPHY

N. HYVÖNEN†, V. KAARNIOJA†, L. MUSTONEN†, AND S. STABOULIS‡

Abstract. The objective of electrical impedance tomography is to reconstruct the internal conductivity of a physical body based on measurements of current and potential at a finite number of electrodes attached to its boundary. Although the conductivity is the quantity of main interest in impedance tomography, a real-world measurement configuration includes other unknown parameters as well: The information on the contact resistances, electrode positions, and body shape is almost always incomplete. In this work, the dependence of the electrode measurements on all aforementioned model properties is parametrized via polynomial collocation. The availability of such a parametrization enables efficient simultaneous reconstruction of the conductivity and other unknowns by a Newton-type output least squares algorithm, which is demonstrated by two-dimensional numerical experiments based on both noisy simulated data and experimental data from two water tanks.

Key words. electrical impedance tomography, polynomial collocation, uncertainty quantification, Bayesian inversion, inaccurate measurement model, complete electrode model

AMS subject classifications. 65N21, 35R30, 35R60, 60H15

DOI. 10.1137/16M1068888

1. Introduction. The objective of electrical impedance tomography (EIT) is to reconstruct the conductivity/admittivity inside a physical body from boundary measurements of electric current and electromagnetic potential. EIT can be applied to, e.g., medical imaging, process tomography, and nondestructive testing of materials [6, 9, 42]. The most accurate way to model the measurements of EIT is employing the complete electrode model (CEM), which takes into account the electrode shapes and contact resistances/impedances caused by resistive layers at electrode-object interfaces [10, 41].

When EIT is used in practice, the conductivity is typically not the only unknown. In particular, the electrode positions, the contact resistances, and the shape of the imaged object are also subject to uncertainties. For example, in a medical application the body shape and the contact resistances obviously depend on the patient, and one cannot assume precise information on the positioning of the electrodes. As it is well known that even slight mismodelling usually ruins the reconstruction of the conductivity in absolute EIT imaging [5, 8, 28], not being able to account for such inaccuracies considerably hampers establishing EIT as a practical imaging modality. Since the contact resistances and the electrode locations can be (stably) estimated at the same time as the conductivity reconstruction is formed by a Newton-type algorithm [12, 43], the most challenging of the aforementioned three sources of uncertainty

*Received by the editors April 4, 2016; accepted for publication (in revised form) September 30, 2016; published electronically January 31, 2017.

http://www.siam.org/journals/siap/77-1/M1068888.html

Funding: The work of the first three authors was supported by the Academy of Finland (decision 267789). The work of the third author was also supported by the Finnish Foundation for Technology Promotion TES. The work of the fourth author was supported by the Danish Council for Independent Research (grant 4002-00123).

†Department of Mathematics and Systems Analysis, Aalto University, FI-00076 Aalto, Finland (nuutti.hyvonen@aalto.fi, vesa.kaarnioja@aalto.fi, lauri.mustonen@aalto.fi).

‡Department of Applied Mathematics and Computer Science, Technical University of Denmark, DK-2800 Kgs. Lyngby, Denmark (ssta@dtu.dk).
is arguably the inaccurately known object shape. In the following, we present a brief
survey of the previously introduced methods for recovering from uncertainties in the
exterior boundary shape in EIT; for a more comprehensive discussion, see [33].

Difference imaging is the simplest technique for handling uncertainties in the
measurement set-up of EIT [4]: Electrode measurements are performed at two time
instants (or angular frequencies [2]), and the corresponding change in the conductivity
(or admittivity) is reconstructed. The main idea is that the modelling errors partly
cancel out when the difference data are formed, assuming there are no alterations
in the boundary shape in between the two measurements, e.g., due to the breathing
cycle of a patient. On the negative side, difference imaging is highly approximative,
as the theoretical grounds for its functionality rely on a linearization of the forward
model. In addition, difference data are not always available.

The first generic algorithm capable of coping with an unknown object boundary
in absolute EIT imaging was introduced in two spatial dimensions by Kolehmainen,
Lassas, and Ola [26, 27]. Allowing an oversimplification, their approach is based on
compensating for the mismodelled geometry by reconstructing a (slightly) anisotropic
conductivity. An obvious weakness of the ideas in [26, 27] is the difficulty in generaliz-
ing the corresponding numerical algorithm to three dimensions. The so-called approx-
imation error methodology [24] was successfully applied to EIT with an inaccurately
known boundary shape in [32, 33]: The error caused by the uncertainties in the model
geometry (and other nuisance parameters) is represented as an auxiliary measurement
noise process whose second order statistics are approximated via simulations based
on the prior probability models for the conductivity and the boundary shape. Subse-
quently, a reconstruction of the conductivity is formed within the Bayesian paradigm.
The most straightforward approach to dealing with an inexactly known body shape
in EIT was introduced in [13, 14], where the Fréchet derivative of the solution to
the CEM with respect to the exterior boundary shape was employed in a regularized
Newton-type output least squares algorithm that simultaneously reconstructs the con-
ductivity, the contact resistances, the electrode positions, and the exterior boundary
of the imaged object. The main weakness of the algorithm in [13, 14] lies with the
numerical instability in the computation of the needed shape derivatives, which ne-
cessitates the use of relatively dense finite element (FE) meshes and thus slows down
the computations to a certain extent.

This work tackles absolute EIT imaging with an unknown object shape by means
of (stochastic) polynomial collocation. The conductivity, the contact resistances,
the electrode positions, and the boundary shape are parametrized by a finite number,
say a thousand, of parameters supported in a bounded interval; in the framework
of stochastic collocation [3], these parameters would be interpreted as uniformly dis-
tributed random variables. The forward problem of the CEM is then treated as a
parametric elliptic boundary value problem whose solution depends not only on the
current feed and the spatial variable but also on the high-dimensional parameter vec-
tor. This forward problem is solved by a (stochastic) collocation finite element method
(cFEM) [3]: The standard CEM problem is first solved with a finite element method
(FEM) for the conductivities and measurement settings defined by an appropriate
sparse grid of collocation points in the parameter hypercube, and subsequently the
dependence of the forward solution on the parameters is generalized to the whole
hypercube via collocation by tensor products of Legendre polynomials. In particular,
such a procedure gives an approximate parametrization of the electrode potentials
with respect to (the parameters defining) the conductivity, the contact resistances,
the electrode positions, and the object shape, which makes it possible to reconstruct
these unknowns, e.g., by Tikhonov regularization or via Bayesian inference. Indeed, the described approach results in a functional reconstruction algorithm that is tested with both simulated and experimental data in a two-dimensional setting. See [19] for a closely related algorithm as well as related theory in inverse obstacle scattering.

Compared to the previous methods for recovering from uncertainties in the geometric specifications of the measurement set-up in EIT, on a general level the introduced algorithm most closely resembles the approximation error technique employed in [32, 33]: Both require heavy off-line computations that can be performed prior to the measurements (to simulate the statistics of the approximation error process or to parametrize the dependence on the unknowns via polynomial collocation), but both also allow a fast on-line reconstruction phase once the measurements become available. For completeness, it should be mentioned that [17, 23] used a stochastic Galerkin FEM (cf., e.g., [38]) as a building block of a Bayesian reconstruction algorithm for EIT under the assumption that the electrode positions and the object shape are known. However, it seems difficult to apply a stochastic Galerkin FEM to handling uncertainties in the measurement configuration of EIT; see, e.g., [19] for similar conclusions.

This text is organized as follows. Section 2 recalls the CEM and presents its parametric extension, while section 3 describes how cFEM can be applied to the CEM. The actual implementation of the reconstruction algorithm is discussed in section 4 and applied to both simulated and experimental data in section 5. Finally, conclusions are drawn in section 6.

2. Complete electrode model and its parametric extension. This section introduces an extension of the CEM, allowing the use of parameter-dependent conductivities, contact resistances, electrode positions, and boundary shapes. For a justification of the standard CEM, see [10, 41]. We work in two spatial dimensions and with \( M \in \mathbb{N} \backslash \{1\} \) electrodes of the same known width, but the generalization to three dimensions and/or to the case of electrodes with unknown shapes is conceptually straightforward.

2.1. Parametrization of the measurement set-up. Let \( N = N_\sigma + N_\gamma + 2M \) denote the number of parameters living in the hypercube

\[
\Upsilon = \Upsilon_\sigma \times \Upsilon_\gamma \times \Upsilon_E \times \Upsilon_z = [-1/2, 1/2]^N.
\]

We decompose \( y = (y_\sigma, y_\gamma, y_E, y_z) \in \Upsilon \), where the subvectors \( y_\sigma \in \Upsilon_\sigma \subset \mathbb{R}^{N_\sigma} \), \( y_\gamma \in \Upsilon_\gamma \subset \mathbb{R}^{N_\gamma} \), \( y_E \in \Upsilon_E \subset \mathbb{R}^M \), and \( y_z \in \Upsilon_z \subset \mathbb{R}^M \) correspond to the parametrizations of the conductivity field, the boundary curve, the electrode positions, and the contact resistances, respectively.

Let us first introduce a parametrization for the boundary curve, that is, a continuous map

\[
\Upsilon_\gamma \ni y_\gamma \mapsto \gamma(\cdot, y_\gamma) \in C_0^{1,1}(\mathbb{R}; \mathbb{R}^2),
\]

where, for every \( y_\gamma \in \Upsilon_\gamma \), \( \gamma(\cdot, y_\gamma) : [0, L) \to \mathbb{R}^2 \) defines a bounded, closed, non-self-intersecting, Lipschitz curve parametrized in the counterclockwise direction. Here and in what follows, the subscript \( L > 0 \) indicates that the elements of the considered function space are \( L \)-periodic. The domain enclosed by

\[
\Gamma(y_\gamma) := \{ \gamma(\phi, y_\gamma) \mid \phi \in [0, L) \}
\]
is denoted \( D(\gamma) \). We assume there exists a natural bi-Lipschitz homeomorphism

\[
\Phi(\cdot, \gamma) : D(\gamma) \to D(0)
\]

for all \( \gamma \in \Upsilon_\gamma \). In our numerical tests, \( D(0) \) is an origin-centered open disk, and the domains \( D(\gamma) \), \( \gamma \in \Upsilon_\gamma \), are star-shaped with respect to the origin, meaning that one can define the mappings \( \Phi(\cdot, \gamma) \) by suitably scaling the distance to the origin; see section 4 for details.

Given a parametrization for the domain boundary, the position of an electrode is determined by a curve parameter corresponding to its starting point. To be more precise, after introducing a suitable mapping

\[
\Upsilon_E \ni y_E \mapsto \theta(y_E) \in [0, L]^M,
\]

the electrodes are parametrized by the set-valued functions,

\[
\Upsilon_\gamma \times \Upsilon_E \ni (\gamma, y_E) \mapsto E_m(\gamma, y_E) \subset \Gamma(\gamma), \quad m = 1, \ldots, M,
\]

where

\[
E_m(\gamma, y_E) := \{ \gamma(\phi, \gamma) \in \Gamma(\gamma) \mid 0 < \text{dist}(\gamma(\theta_m(y_E), \gamma), \gamma(\phi, \gamma)) < \omega \}
\]

with \( \text{dist}(x,z) \) denoting the distance between the points \( x, z \in \Gamma(\gamma) \) along \( \Gamma(\gamma) \) in the counterclockwise direction and \( \omega \) being the known width of the electrodes. The mapping \( \theta : \Upsilon_E \to [0, L]^M \) is assumed to be continuous, when \( L \) is identified with 0 on the image side, and to satisfy the condition

\[
\min_{j \neq k} \min_{y_E \in \Upsilon_E} \min_{y, y \in \Upsilon_\gamma} \text{dist}(\gamma(\theta_j(y_E), \gamma), \gamma(\theta_k(y_E), \gamma)) \geq \omega,
\]

which guarantees that the electrodes do not overlap or change their order. (In our numerical tests, the parametrization is slightly simpler, as the \( m \)th starting parameter \( \theta_m \) depends only on the corresponding component of \( y_E \).)

The conductivity field is parametrized by first introducing the dependence on \( y_\sigma \) in the “ unperturbed” reference domain \( D(0) \) with the help of a continuous mapping

\[
\Upsilon_\sigma \ni y_\sigma \mapsto \sigma_0(\cdot, y_\sigma) \in L^\infty_+(D(0)) := \{ \kappa \in L^\infty(D(0)) \mid \text{ess inf} \kappa > 0 \},
\]

and then defining the actual domain-dependent parametrization via

\[
\Upsilon_\sigma \times \Upsilon_\gamma \ni (y_\sigma, y_\gamma) \mapsto \sigma(\cdot, y_\sigma, y_\gamma) := \sigma_0(\Phi(\cdot, y_\gamma), y_\sigma) \in L^\infty_+(D(y_\gamma)).
\]

Finally, the contact resistances \( z \in \mathbb{R}_+^M \) are parametrized simply by a continuous map

\[
\Upsilon_z \ni y_z \mapsto z(y_z) \in \mathbb{R}_+^M,
\]

where, in fact, \( z_m, m = 1, \ldots, M \), depends only on the corresponding component of \( y_z \).

In what follows, we often write \( \gamma^y = \gamma(\cdot, y_\gamma), \quad \Gamma^y = \Gamma(y_\gamma), \quad D^y = D(y_\gamma), \quad \Phi^y = \Phi(\cdot, y_\gamma), \quad E_m^y = E_m(y_\gamma, y_E), \quad \sigma^y = \sigma(\cdot, y_\sigma, y_\gamma), \quad \text{and} \quad z^y = z(y_z) \) to simplify the notation.
2.2. Parameter-dependent CEM. Assume that the parametrizations (2.1), (2.3), (2.5), and (2.6) are given, denote by \( \mathbb{R}_\nu^M \) the mean-free subspace of \( \mathbb{R}^M \), and let \( I \in \mathbb{R}^M_\nu \) define the net current feeds through the electrodes. According to the CEM [10], for a fixed parameter vector \( y \in \mathcal{Y} \), the electromagnetic potential \( u^y \) inside \( D^y \) and the potentials \( U^y \in \mathbb{R}^M \) on the electrodes satisfy the elliptic boundary value problem

\[
\begin{aligned}
\nabla \cdot (\sigma^y \nabla u^y) &= 0 & \text{in } D^y, \\
\frac{\partial u^y}{\partial \nu} &= 0 & \text{on } \Gamma^y \setminus \overline{E^y}, \\
u u^y + \nu^y \mathcal{M}^y \frac{\partial u^y}{\partial \nu} &= U^y_m & \text{on } E^y_m, & m = 1, \ldots, M, \\
\int_{E^y_m} \sigma^y \frac{\partial u^y}{\partial \nu} \, dS &= I_m, & m = 1, \ldots, M,
\end{aligned}
\]

where \( \nu = \nu(x) \) denotes the exterior unit normal of \( \Gamma^y \) and \( E^y = \bigcup_{m=1}^M E^y_m \). It follows immediately from the material in [41] and the properties of the parametrizations introduced in section 2.1 that (2.7) has a unique solution \((u^y, U^y)\) \( \in (H^1(D^y) \oplus \mathbb{R}^M) / \mathcal{R} := \mathcal{H}^y \) for all \( y \in \mathcal{Y} \). Moreover, one can write a relatively explicit \( y \)-independent estimate for the \( \mathcal{H}^y \)-norm of \((u^y, U^y)\), as revealed by the following analysis.

The variational formulation of (2.7) is to find \((u^y, U^y)\) \( \in \mathcal{H}^y \) such that [41]

\[
B^y((u^y, U^y),(v, V)) = I \cdot V \quad \text{for all } (v, V) \in \mathcal{H}^y,
\]

where the bilinear form \( B^y : \mathcal{H}^y \times \mathcal{H}^y \to \mathbb{R} \) is defined as

\[
B^y((w, W), (v, V)) = \int_{D^y} \sigma^y \nabla w \cdot \nabla v \, dx + \sum_{m=1}^M \frac{1}{z_m} \int_{E^y_m} (W_m - w)(V_m - v) \, dS.
\]

Let us define

\[
\zeta_- = \min_{y_\sigma \in \mathcal{Y}_\sigma} \text{ess inf} \sigma_0(\cdot, y_\sigma), \quad \zeta_+ = \max_{y_\sigma \in \mathcal{Y}_\sigma} \|\sigma_0(\cdot, y_\sigma)\|_{L^\infty(D(0))}
\]

and

\[
\zeta_-=\min_{m} \min_{y_\sigma \in \mathcal{Y}_z} z_m(y_\sigma), \quad \zeta_+=\max_{m} \max_{y_\sigma \in \mathcal{Y}_z} z_m(y_\sigma).
\]

Furthermore, let \( C_{y, tr} > 0 \) be the norm of the trace operator

\[
\text{tr} : v \mapsto v|_{\Gamma^y}, \quad H^1(D^y) \to L^2(\Gamma^y),
\]

and let \( C_{y, P} > 0 \) be the Poincaré–Wirtinger constant for \( D^y \), that is, the smallest constant such that

\[
\|v - \bar{v}\|_{H^1(D^y)} \leq C_{y, P} \|\nabla v\|_{L^2(D^y)} \quad \text{for all } v \in H^1(D^y),
\]

where \( \bar{v} \in \mathbb{R} \) denotes the mean of \( v \) over \( D^y \). Finally, set

\[
C_{tr} = \sup_{y \in \mathcal{Y}} C_{y, tr}, \quad C_P = \sup_{y \in \mathcal{Y}} C_{y, P}.
\]

Note that the dependence of the trace norm on the corresponding domain is an active research topic; see, e.g., [37] and the references therein. On the other hand, consult [7] for a result that could be applied to the Poincaré–Wirtinger constant in our setting. In the following, we simply assume that both \( C_{tr} \) and \( C_P \) are finite.
Theorem 2.1. The bilinear form $B^\epsilon: \mathcal{H}^\epsilon \times \mathcal{H}^\epsilon \to \mathbb{R}$ is uniformly bounded and coercive; that is,
\[
B^\epsilon((w, W), (v, V)) \leq \max \left\{ \frac{2C^2}{\zeta_-}, \frac{2\omega}{\zeta_-} \right\} \|w, W\|_{\mathcal{H}^\epsilon} \|v, V\|_{\mathcal{H}^\epsilon}
\]
and
\[
B^\epsilon((v, V), (v, V)) \geq \left( \max \left\{ \frac{C^2}{\zeta_-} \left( 1 + \frac{2C^2}{\omega} \right), \frac{2\zeta_+}{\omega} \right\} \right)^{-1} \|v, V\|^2_{\mathcal{H}^\epsilon}
\]
for all $y \in \mathcal{Y}$.

Proof. The result follows by keeping track of the constants in [21, Proof of Lemma 2.5] and accounting for the slight difference between the $H$-norm employed in [21] and the natural norm of $\mathcal{H}^\epsilon$, i.e.,
\[
\|v, V\|^2_{\mathcal{H}^\epsilon} := \inf_{c \in \mathbb{R}} \left( \|v - c\|^2_{H^1(D^\epsilon)} + |V - c|^2 \right),
\]
where $1 = (1, \ldots, 1) \in \mathbb{R}^M$. □

Corollary 2.2. The solution of (2.7) satisfies the uniform bound
\[
\|(u^\epsilon, U^\epsilon)\|_{\mathcal{H}^\epsilon} \leq \max \left\{ \frac{C^2}{\zeta_-} \left( 1 + \frac{2C^2}{\omega} \right), \frac{2\zeta_+}{\omega} \right\} |I|
\]
for all $y \in \mathcal{Y}$.

Proof. The claim is a direct consequence of the Lax–Milgram lemma. □

For the convergence of (standard) FEM, it is essential to have control over the behavior of the higher Sobolev norms of $u^\epsilon \in H^1(D^\epsilon)/\mathbb{R}$. To this end, denote by $C^\epsilon \geq 0$ the norm of the zero continuation operator from $H^{1/2-\epsilon}(E^\epsilon)$ to $H^{1/2-\epsilon}(\Gamma^\epsilon)$, $0 < \epsilon < 1$, and by $\tilde{C}^\epsilon \geq 0$ the norm of the solution mapping
\[
H^{1/2-\epsilon}(\Gamma^\epsilon) \ni f^\epsilon \mapsto v^\epsilon \in H^{2-\epsilon}(D^\epsilon)/\mathbb{R},
\]
corresponding to the Neumann problem
\[
\nabla \cdot (\sigma^\epsilon \nabla v^\epsilon) = 0 \quad \text{in } D^\epsilon, \quad \sigma^\epsilon \frac{\partial v^\epsilon}{\partial \nu} = f^\epsilon \quad \text{on } \Gamma^\epsilon.
\]

Moreover, let $\hat{C}^\epsilon$ be the norm of the Neumann-to-Dirichlet map
\[
L^2(\Gamma^\epsilon) \ni f^\epsilon \mapsto v^\epsilon|_{\Gamma^\epsilon} \in H^1(\Gamma^\epsilon)/\mathbb{R},
\]
where $L^2(\Gamma^\epsilon)$ is the mean-free subspace of $L^2(\Gamma^\epsilon)$. Finally, set
\[
C_\epsilon = \sup_{y \in \mathcal{Y}} C^\epsilon, \quad \tilde{C}_\epsilon = \sup_{y \in \mathcal{Y}} \hat{C}^\epsilon, \quad \hat{C} = \sup_{y \in \mathcal{Y}} \hat{C}^\epsilon.
\]

It is once again assumed that the parametrization of our measurement setting is regular enough to make these definitions unambiguous as well as $C_\epsilon$, $\tilde{C}_\epsilon$, and $\hat{C}$ finite for the considered $0 < \epsilon < 1$ (cf. [1, 30]).

Corollary 2.3. Let $C_1 > 0$ be the constant on the right-hand side of (2.11). For any $0 < \epsilon < 1$, the first part of the solution to (2.7) satisfies the uniform bound
\[
\|(u^\epsilon)\|_{H^{2-\epsilon}(D^\epsilon)/\mathbb{R}} \leq \sqrt{2C_\epsilon} \tilde{C}_\epsilon \left( \hat{C} + 1 \right) \max \{C_{\epsilon_{tr}}, \sqrt{\omega} \} C_1 |I|
\]
for all $y \in \mathcal{Y}$. 

Copyright © by SIAM. Unauthorized reproduction of this article is prohibited.
Proof. By definition,
\[
\|u^y\|_{H^{2-\epsilon}(D^y)\times R} \leq \tilde{C}_c \left\| \sigma_y \frac{\partial u^y}{\partial \nu} \right\|_{H^{1/2-\epsilon}(\Gamma^y)} \leq C_c \tilde{C}_c \left\| \sigma_y \frac{\partial u^y}{\partial \nu} \right\|_{H^1(E^y)},
\]
where we also used the trivial embedding \(H^1(E^y) \subset H^{1/2-\epsilon}(E^y)\) to deduce the second inequality. Now the claim follows by carefully keeping track of the constants in [18, Proof of Lemma 3.1] and [22, Proof of Lemma 2.1].

Observe that the constants appearing on the right-hand side of (2.12) are not independent of each other: For example, the norm of the zero continuation \(C_c\) certainly depends on \(\omega > 0\), and obviously \(\tilde{C}_c\) and \(C_{tr}\) are intimately connected. Moreover, the estimate (2.12) is not optimal; as an example, consult [11, 15] for more careful analysis of the dependence on \(\epsilon\). Be that as it may, (2.12) arguably gives a general idea of how the parametrization of the measurement configuration affects the bound on the \(H^{2-\epsilon}(D^y)\)-norm of the interior potential.

Remark 2.4. Although the estimate on the \(H^{2-\epsilon}(D^y)\)-norm of the electromagnetic potential (2.12) is connected to the accuracy of the numerical forward solution at the chosen sparse grid points over \(\Upsilon\) (cf. section 3), from the standpoint of efficient polynomial collocation it would be more important to prove analytic dependence of the solution pair \((u^y, U^y)\) on the parameter vector \(y \in \Upsilon\); see, e.g., [3]. However, such investigations are left for future studies.

In the following, we systematically choose the ground level of potential by identifying \((H^1(\Omega) \oplus \mathbb{R}^M)/\mathbb{R} \simeq H^1(\Omega) \oplus \mathbb{R}_\circ^M\).

3. cFEM applied to the CEM. In this section we describe how the parameter-dependent CEM forward problem is discretized in both spatial and parametric dimensions. Let \(I \in \mathbb{R}^{M \times (M - 1)}\) denote a current matrix whose columns form an arbitrary but fixed basis for the space of feasible net current feeds, that is, for \(\mathbb{R}^M\). The corresponding numerical solutions \(U^y \in \mathbb{R}^{M \times (M - 1)}\) for the electrode potentials in problem (2.7) (or in its variational formulation (2.8)) with a fixed \(y \in \Upsilon\) can be computed by using standard FE techniques; recall that \(y = (y_\gamma, y_\gamma, y_E, y_z)\) defines the conductivity, the contact resistances, and the geometric set-up for the forward problem (2.7). We continue to assume that the ground level of potential is chosen such that each column of \(U^y\) has zero mean. It is straightforward to show that, due to the linear dependence on the current pattern \(I\) in (2.8), the solutions \(U^y\) corresponding to another current matrix \(\tilde{I}\) satisfy \(\tilde{U}^y = U^y \tilde{I}\tilde{I}^\dagger\), where \((\cdot)^\dagger\) denotes the Moore–Penrose pseudoinverse. Thus, we pay no attention to choosing the current feeds in what follows.

By requiring the variational formulation (2.8) to hold for all \(M - 1\) current patterns and for all FEM basis functions, we end up with a matrix equation

\[
\begin{aligned}
A^y v^y &= F^y,
\end{aligned}
\]
where the stiffness matrix \(A^y\) depends on all parameters \(y \in \Upsilon\), and \(F^y\), having \(M - 1\) columns, depends only on the subvectors \(y_\gamma\) and \(y_E\) (through the meshing of \(D^y\)). Ultimately, we are interested only in those \(Q := M(M - 1)\) elements of the unknown matrix \(v^y\) that define the electrode potentials \(U^y\).

The aim of the cFEM is to construct an explicit parameter dependence into the numerical solution. More precisely, we seek a polynomial mapping

\[
\Upsilon \ni y \mapsto U(y) \in \mathbb{R}^Q
\]
so that \( U(y) \approx U^\nu \) elementwise. For notational convenience, we actually consider \( U(y) \) as a vector that is obtained by stacking the matrix columns on top of each other. We write the numerical parametric solution in the form

\[
(U(y))_q = \sum_{p=1}^{P} \hat{U}_{q,p} \mathcal{L}_p(y), \quad q = 1, \ldots, Q,
\]

where \( \hat{U}_{q,p} \in \mathbb{R} \) and \( \mathcal{L}_p \) are suitably scaled Legendre polynomials in \( N \) variables (cf. [16]). It remains to choose the actual set of polynomials and also to determine the coefficient matrix \( \hat{U} \in \mathbb{R}^{Q \times P} \).

We henceforth assume that the polynomial basis is normalized as

\[
\int_{\Upsilon} \mathcal{L}_p(y) \mathcal{L}_{p'}(y) \, dy = \delta_{p,p'}, \quad p, p' = 1, \ldots, P,
\]

where \( \delta_{p,p'} \) denotes the Kronecker symbol defined to be unity whenever its indices coincide, and vanishing otherwise. Performing a discrete projection of the parametric solution (3.2) onto the tensorized Legendre polynomial basis \( (\mathcal{L}_p)_{p=1}^{P} \) in \( \Upsilon \) yields a representation of the coefficients given by the integrals

\[
\hat{U}_{q,p} = \int_{\Upsilon} (U(y))_q \mathcal{L}_p(y) \, dy, \quad q = 1, \ldots, Q, \quad p = 1, \ldots, P,
\]

which we approximate by a sparse grid quadrature based on nested Clenshaw–Curtis rules. The sparse grid method was first introduced in [40], and comprehensive analyses of its approximation properties were developed later in [35, 36, 44]. The application of sparse grid quadratures to collocation methods was pioneered in the context of parametric partial differential equations in such works as [3, 45]. In the following, we give a brief overview of these techniques applied to the problem considered in this paper.

The sparse grid method is based on extending a family of univariate quadrature rules into the high-dimensional parametric region \( \Upsilon \subset \mathbb{R}^N \) by considering a sparsity-promoting linear combination of tensorized collections of univariate quadrature operators. The nested Clenshaw–Curtis rules in the interval \([-1/2, 1/2]\) are based on the sequence \( m(1) = 1 \) and \( m(n) = 2^{n-1} + 1 \) for \( n > 1 \), which corresponds to the abscissae \( y_{1}^{(1)} = 0 \) and

\[
y_{k}^{(n)} = -\frac{1}{2} \cos \left( \frac{(k - 1)\pi}{m(n) - 1} \right), \quad k = 1, \ldots, m(n), \quad n \in \mathbb{N} \setminus \{1\}.
\]

The abscissae characterize a sequence of positive weights \( (w_k^{(n)})_{k=1}^{m(n)} \) that define the Clenshaw–Curtis quadrature rules

\[
Q_n f = \sum_{k=1}^{m(n)} w_k^{(n)} f(y_k^{(n)}) \approx \int_{-1/2}^{1/2} f(y) \, dy,
\]

which are exact for all polynomials of degree not more than \( m(n) \). The tensor products of these quadrature operators are defined as

\[
\bigotimes_{k=1}^{N} Q_{\alpha_k} f = \sum_{i_1=1}^{m(\alpha_1)} \cdots \sum_{i_N=1}^{m(\alpha_N)} w_{i_1}^{(\alpha_1)} \cdots w_{i_N}^{(\alpha_N)} f(y_{i_1}^{(\alpha_1)}, \ldots, y_{i_N}^{(\alpha_N)}),
\]
where $\alpha_k \in \mathbb{N}$ for $1 \leq k \leq N$.

A particular case of sparse grid quadrature is the well-known Smolyak's construction [44]. The $N$-dimensional Smolyak rule of order $K \geq 0$ based on the nested Clenshaw–Curtis rules is given by

$$Q_{N,K} = \sum_{\max\{N,K+1\} \leq |\alpha| \leq N+K} (-1)^{N+K-|\alpha|} \binom{N-1}{N+K-|\alpha|} \prod_{k=1}^{N} Q_{\alpha_k},$$

where $\alpha = (\alpha_1, \ldots, \alpha_N) \in \mathbb{N}^N$ and $|\alpha| = \alpha_1 + \cdots + \alpha_N$. The function evaluations are carried out in the sparse grid

$$\Theta_{N,K} = \bigcup_{|\alpha| = N+K} \Theta_{\alpha_1} \times \cdots \times \Theta_{\alpha_N},$$

where $\Theta_n = \{y^{(n)}_{k}\}_{k=1}^{m(n)}$. The sparse grid $\Theta_{N,K}$ has the asymptotic cardinality

$$n_{N,K} := \#\Theta_{N,K} \sim \frac{2^K}{K!} N^K$$

as $N$ tends to infinity for a fixed $K$ [36]. By tabulating the collocation nodes $(y^{(N,K)}_{k})_{k=1}^{n_{N,K}}$ in $\Theta_{N,K}$ and their respective weights $(w^{(N,K)}_{k})_{k=1}^{n_{N,K}}$, the Smolyak quadrature rule can be rewritten as a cubature rule

$$Q_{N,K} f = \sum_{k=1}^{n_{N,K}} w^{(N,K)}_{k} f(y^{(N,K)}_{k}).$$

The Smolyak rule generalizes the polynomial exactness of the underlying univariate rules [35]. Let $\Pi^1_{K}$ denote the space of all polynomials in $N$ variables of total degree at most $K$. Then

$$Q_{N,K} f = \int_{\Upsilon} f(y) \, dy$$

for all multivariate polynomials $f$ such that

$$f \in \bigotimes_{|\alpha|=N+K} (\Pi^1_{m(\alpha_1)} \otimes \cdots \otimes \Pi^1_{m(\alpha_N)}).$$

In particular, it can be shown that the rule is exact for all $f \in \Pi^1_{2K+1}$ whenever $K < 3N$ [36]. For $K \geq 3N$, the related total degree space is different and we omit it. The coefficients $\hat{U}_{q,p} \in \mathbb{R}$ that appear in the operator (3.2) can now be approximated by using the cubature rule

$$(3.3) \quad \hat{U}_{q,p} \approx Q_{N,K}(\mathcal{U}(\cdot)|_{q} \mathcal{L}_{p}) = \sum_{k=1}^{n_{N,K}} w^{(N,K)}_{k} [\mathcal{U}(y^{(N,K)}_{k})]_{q} \mathcal{L}_{p}(y^{(N,K)}_{k}),$$

where the needed nodal evaluations of $\mathcal{U}(\cdot)$ are replaced by those of the FEM solutions $\mathcal{U}^{(i)}$. The error accumulation of the collocated solution depends on the error introduced in the numerical solution of the CEM for fixed realizations of the parameter $y \in \Upsilon$, the truncation error that stems from the representation (3.2), and the aliasing error caused by the cubature rule (3.3).
4. Implementation. As emphasized in, e.g., [23], an EIT inversion algorithm based on stochastic or parametric FEM consists of two distinct parts. In the premeasurement processing, the explicit parameter dependence (3.2) is constructed by using cFEM. Unlike in [23], we do not assume that the geometry of the measurement setting is known during the premeasurement processing, but instead include parameters for the boundary curve and electrode positions in the cFEM problem.

In the postmeasurement processing, the parametric solution is fitted to the measurement data with respect to the parameter vector $y$. This part is often treated as a least squares minimization problem, which involves either a Tikhonov functional or a maximum a posteriori (MAP) estimator in a Bayesian approach. Once a minimizing least squares minimization problem, which involves either a Tikhonov functional or a MAP estimator in a Bayesian approach. Once a minimizing vector $y \in \Upsilon$ is found, recovering the quantities of interests follows straightforwardly by considering the mappings introduced in the premeasurement step.

4.1. Premeasurement processing. This subsection introduces one possible set of concrete mappings that were abstractly given in section 2.1. That is, we consider functions that map the parameter vectors $y_\gamma$, $y_E$, $y_\sigma$, and $y_c$ to boundary curve, electrode positions, conductivity field, and contact resistances, respectively. We will frequently use the fact that the components of the parameter vectors lie in the interval $[-1/2, 1/2]$. The mappings introduced here are certainly not the only feasible ones.

The boundary curve $\Gamma(y_\gamma)$ is represented as a perturbed circle, where the amount of perturbation is determined by a linear combination of $N_\gamma \geq 3$ quadratic B-splines (cf., e.g., [20]). To this end, we choose $L = 2\pi$ in (2.1) and write

$$\gamma(\phi, y_\gamma) = (r(\phi, y_\gamma), \phi)$$

in polar coordinates. We then choose the maximum radial perturbations

$$\rho_- = \min_{\phi \in [0, 2\pi]} \min_{y_\gamma \in \Upsilon_\gamma} r(\phi, y_\gamma), \quad \rho_+ = \max_{\phi \in [0, 2\pi]} \max_{y_\gamma \in \Upsilon_\gamma} r(\phi, y_\gamma)$$

and set $\rho_0 = (\rho_- + \rho_+)/2$. The radial coordinate for $\gamma$ can now be written as

$$r(\phi, y_\gamma) = \rho_0 + \sum_{i=1}^{N_\gamma} (\rho_+ - \rho_-)[y_\gamma_i] \psi_i(\phi),$$

where $\psi_i \in C^1_{2\pi}(\mathbb{R})$ are nonnegative and uniform quadratic B-splines that form a partition of unity. The unperturbed case $y_\gamma = 0$ corresponds to a circle with radius $\rho_0$, i.e., $D(0)$ is a disk of radius $\rho_0$. Each spline satisfies $|\text{supp}(\psi_i) \cap [0, 2\pi]| = 6\pi/N_\gamma$. Thus, the deformations are local, as illustrated in Figure 1. We define the homeomorphism (2.2) as

$$\Phi(\gamma', \phi, y_\gamma) = \left( \frac{\rho_0}{r(\phi, y_\gamma)} \gamma', \phi \right),$$

which holds whenever $\gamma', \phi, y_\gamma \in D(y_\gamma)$.

For all $y_E \in \Upsilon_E$, we define the starting angles of the electrodes as

$$\theta_m(y_E) = (m - 1)\frac{2\pi}{M} + 2\alpha[y_E]_m, \quad m = 1, \ldots, M.$$

Here, the offset parameter $\alpha \geq 0$ is sufficiently small so that the nonoverlapping condition (2.4) is satisfied. (Actually, the existence of such $\alpha$ also requires that $\rho_-$ be sufficiently large compared to $\omega$. To be more precise, the combined width of the
electrodes must always be less than the circumference of the boundary, i.e., $2\pi \rho_- > M\omega$, but this is assumed to be true for the employed parametrization.) Because in EIT the absolute orientation of the imaged object in space cannot be determined, we can as well fix one of the starting angles and decrease the number of parameters by one. For simplicity, however, we keep $N$ as defined and fix the starting angle of the first electrode by (re-)defining $\theta_1(y_E) = 0$ for all $y_E \in \Upsilon_E$.

We resort to a piecewise constant representation for the conductivity. Other possible choices include Karhunen–Loève eigenfunctions corresponding to a (prior) random field and suitable FEM basis functions. We partition the canonical domain $D(0)$ into $N_\sigma$ pairwise disjoint subdomains that satisfy

$$\bigcup_{i=1}^{N_\sigma} \chi_i^{-1}(1) = D(0),$$

where $\chi_i$ is the indicator function of the $i$th subdomain. An example partitioning is shown in Figure 1. For $x \in D(0)$, the canonical conductivity $\sigma_0$ is defined as

$$\sigma_0(x, y_\sigma) = \sum_{i=1}^{N_\sigma} \chi_i(x) \exp \left(\frac{1}{2} \log(\varsigma_- \varsigma_+) + \log \left(\frac{\varsigma_+}{\varsigma_-}\right) \right)[y_\sigma]_i$$

for some given values $0 < \varsigma_- \leq \varsigma_+$. It is easy to see that (4.4) satisfies (2.9). The domain-dependent parametrization of the conductivity follows from (2.5) and (4.2). The contact resistances are defined according to

$$z_m(y_z) = \exp \left(\frac{1}{2} \log(\varsigma_- \varsigma_+) + \log \left(\frac{\varsigma_+}{\varsigma_-}\right) \right)[y_z]_m, \quad m = 1, \ldots, M,$$

which agrees with (2.10).

Typically, the number of parameters defining the conductivity field is much higher than the number of boundary curve parameters. In Figure 1, for example, we have chosen $N_\sigma = 960$, whereas $N_\gamma = 16$. On the other hand, the number of parameters defining the contact resistances and electrode positions is directly determined by the number of electrodes, which is usually quite low. Due to the structure of a typical sparse collocation grid, the number of different computational domains and FE meshes...
is therefore moderate compared to the total number of collocation points. In fact, most of the forward problems in our numerical examples are computed in the canonical domain $D(0)$ with equiangled electrodes and with contact resistances set to $z(0)$. These problems merely correspond to perturbing a few values in the stiffness matrix $A^y$ in (3.1).

The computations in the premeasurement phase are easily parallelizable, and there may also exist a lot of exploitable symmetries. For example, if the conductivity is discretized as in Figure 1, the number of electrodes is divisible by eight, and the current matrix involves certain symmetries, then solving a forward problem corresponding to a conductivity node (i.e., a collocation node where only $y_\sigma$ contains nonzero values) simultaneously solves several problems where both current feed and the conductivity field are rotated. Only reordering of the resulting potential values is required. Similar symmetries may arise, e.g., when the boundary curve is perturbed but other components are fixed. Exploiting these symmetries is beyond the scope of this article.

4.2. Postmeasurement processing. The aim of the postmeasurement processing is to fit the parametric solution (3.2) to measurement data; once again, recall that $y \in \Upsilon$ appearing in (3.2) parametrizes the conductivity, the contact resistances, and the geometric set-up for (2.7). Let $V \in \mathbb{R}^Q$ denote a vector of noisy potential measurements corresponding to some known set of current feeds. As mentioned in the beginning of section 3, the actual current values can be arbitrary as long as they are known and they form a proper basis. Moreover, the linearity with respect to the applied current pattern implies that uncertainties in the current feeds can be assumed to be propagated to the measurement errors of potentials. In this paper, we tackle the inverse problem of EIT by considering a nonlinear least squares problem of the form

$$\min_{y \in \Upsilon} \left\{ |U(y) - V|^2 + \lambda^2 |R(y)|^2 \right\},$$

where $\lambda \geq 0$ is a regularization parameter and $R: \mathbb{R}^N \to \mathbb{R}^{N'}$ is a differentiable regularization operator for an arbitrary $N' \in \mathbb{N}$. Notice that the connection between a (local) minimizer of (4.6) and (regularized) solutions of the underlying undiscretized inverse problem of EIT in the framework of the CEM is nontrivial to analyze; see, e.g., [19, 39] for related considerations.

We refer the reader to [34] for discussion about nonlinear least squares algorithms. In short, most algorithms are based on successive linearizations and require evaluating both $U(y)$ and $R(y)$, as well as their Jacobian matrices for different values of $y \in \Upsilon$. The reconstructions in section 5 are obtained by using the \texttt{lsqnonlin} function in MATLAB with a user-supplied Jacobian. It is shown in [31] that the cost of evaluating $U(y)$ and its Jacobian is $O(QN^k)$, where $k$ is the largest polynomial (total) degree in the chosen $P$-dimensional polynomial subspace. On the other hand, solving a linearized least squares subproblem typically has a complexity of $O(QN^2)$, assuming that $N' \leq N$.

As the regularization operator we use a block-diagonal matrix $R \in \mathbb{R}^{N \times N}$ containing blocks $R_\sigma \in \mathbb{R}^{N_\sigma \times N_\sigma}$, $R_\gamma \in \mathbb{R}^{N_\gamma \times N_\gamma}$, $R_E \in \mathbb{R}^{M \times M}$, and $R_z \in \mathbb{R}^{M \times M}$. The conductivity block $R_\sigma$ is defined via its inverse Cholesky factor; that is,

$$[R_\sigma^{-T}R_\sigma^{-1}]_{i,j} = \kappa_\sigma^2 \exp\left(-\frac{|x_i - x_j|^2}{2\beta^2}\right) + \varepsilon \delta_{i,j}, \quad i, j = 1, \ldots, N_\sigma,$$
where $\kappa_\nu, \beta, \varepsilon > 0$ are free parameters to be specified by the operator of the algorithm and $x_i \in D(0)$ is the polar mean of the $i$th subdomain of $D(0)$, i.e., the point defined by the mean values of the polar coordinates in that subdomain. Loosely speaking, this corresponds to the assumption that the conductivity is a priori a log-normal random field with variance-like parameter $\kappa_\nu^2$ and correlation length $\beta$; the role of the small parameter $\varepsilon$ is just to guarantee the invertibility of the matrix. We could as well write $R_\sigma = R_\sigma(y_\gamma)$ and compute the distances in perturbed domains, but this would cause extra work with insignificant effect on the reconstruction.

The (Cholesky factors of the) regularization matrices $R_\gamma$, $R_E$, and $R_z$ are diagonal, i.e.,

$$
R_\gamma = \kappa_\gamma^{-1}I, \quad R_E = \kappa_E^{-1}I, \quad R_z = \kappa_z^{-1}I,
$$

where $I$ denotes an identity matrix of the appropriate size and $\kappa_\gamma, \kappa_E, \kappa_z > 0$ are regularization parameters. If (4.6) were considered as computation of a MAP estimate within the Bayesian paradigm, the positive parameters $\kappa_\gamma, \kappa_E$, and $\kappa_z$ would act as the standard deviations of the (independent) zero-mean Gaussian priors for the components of $y_\gamma$, $y_E$, and $y_z$, respectively (cf., e.g., [25]). In particular, under the Bayesian interpretation, the prior for the contact resistances is log-normal (cf. (4.5)), and those for the electrode angles and the coefficients of the spline-like boundary perturbations are Gaussian.

5. Numerical experiments. We demonstrate the feasibility of the proposed method by numerical experiments in two spatial dimensions. First, the parametric solution $\mathcal{U}(y)$ is constructed as explained in sections 3 and 4.1. The conductivity is discretized with $N_\sigma = 960$ parameters as in Figure 1. For the boundary curve, we choose $N_\gamma = 16$ splines, and the number of electrodes is $M = 16$. Thus, the total number of parameters is $N = 1008$. By using the notation of section 4.1, we choose the minimum and maximum radii as $(\rho_-, \rho_+) = (15, 20)$. The width of the electrodes is $\omega = 2$, and the maximum offset for an electrode angle is $\alpha = 0.1$ radians, i.e., 5.73 degrees. For the conductivity and the contact resistances we choose $(\gamma_-, \gamma_+) = (0.1, 1)$ and $(\epsilon_-, \epsilon_+) = (0.05, 1)$, respectively. (In the tests based on experimental data, the units of length, conductivity, and contact resistance are cm, mS/cm, and kΩ cm, respectively.)

The tensorized Legendre polynomial basis $(Z_p^\nu)_{p=1}^{P}$ is chosen such that it spans the space containing all bilinear, linear, and constant polynomials in $N$ variables. This results in $P = (N^2 + N)/2 + 1 = 508 \, 537$, and the complexity of evaluating $\mathcal{U}(y)$ and its Jacobian matrix becomes $O(QN^2)$. The Smolyak rule of order $K = 2$ based on the nested Clenshaw–Curtis rules is used in the computation of the coefficients $\hat{U}_{q,p}$. This rule is exact for integrands in $\Pi_N^N$, i.e., for all $N$-variate polynomials of total degree at most 5, resulting in 2034 145 collocation nodes in (3.3). The corresponding CEM forward problems are solved by a standard FEM with about 2000 piecewise linear basis functions and appropriate refinement of the employed meshes close to the electrodes. Recall that these forward problems can be solved in parallel. With our hardware (53GB RAM, Intel Xeon X5650 CPU) and nonoptimized MATLAB implementation, this premeasurement phase of forming (3.2) took a few hours. In what follows, we employ the same parametric forward solution in all reconstructions, except for the fixed-geometry reconstructions (see Figures 4 and 7), which for comparison

---

Footnote: The electrode configurations for the targets in Figures 2 and 5 are compatible with this assumption on the angular offset (modulo rotation and/or translation of the domain), but those in Figure 6 are not, though the discrepancy is not huge.
are computed by setting $\rho_- = \rho_+$ and $\alpha = 0$ in the premeasurement phase.

As mentioned in section 4.2, the inverse problem is also solved with MATLAB. We actually treat the problem (4.6) as an unconstrained minimization problem and solve it by *lsqnonlin* with zero initial vector\(^2\) and the Levenberg-Marquardt option, because this is simple and easily reproducible, and there is no reason to expect that some other technique would result in a significantly more accurate localization of a minimizer for (4.6). Apart from $\lambda > 0$, we use the same values for the free parameters of the postmeasurement processing in all numerical tests, namely $\beta = 4$, $\varepsilon = 10^{-4}$, and $\kappa_\sigma = \kappa_\gamma = \kappa_E = \kappa_z = 0.25$ (cf. section 4.2). Making these parameters case-specific would certainly improve the reconstructions to a certain extent, but it would also conflict with our aim of demonstrating that a generic set of parameter values leads to good reconstructions both with simulated data and for different experimental settings. Recall that within the Bayesian paradigm, $\kappa_\sigma$, $\kappa_\gamma$, $\kappa_E$, and $\kappa_z$ can be interpreted as the prior standard deviations for the components of $y_\sigma$, $y_\gamma$, $y_E$, and $y_z$, respectively, meaning that the sizes of the former indicate the amount of variation one expects in the latter a priori. Combining this observation with the parametrizations (4.1) and (4.3)–(4.5) indicates how much fluctuation is expected in the boundary curve, the electrode positions, the pixel values of the conductivity, and the contact resistances, respectively, prior to the measurements. Moreover, the choice of the correlation length $\beta > 0$ is related to the anticipated characteristic length of conductivity variations inside the imaged object.

Unless otherwise stated, the postmeasurement processing phase lasted only a few seconds on a modern desktop computer.

**5.1. Simulated data.** Let us first consider simulated measurements. The considered artificial target conductivities and body shapes are shown in the left-hand column of Figure 2. Neither of the two boundary curves can be exactly represented by the parametrization (4.1) with $N_\gamma = 16$. For both phantoms, there are sixteen electrodes of two units width distributed somewhat evenly along the respective boundary curve. The corresponding contact resistances are similar random perturbations; see Figure 3 for the details. The employed current patterns, i.e., the columns of $I$, are

$$I^m = e_1 - e_{m+1}, \quad m = 1, \ldots, M - 1,$$

with $e_m$ denoting the $m$th Euclidean basis vector of $\mathbb{R}^M$. The electrode measurements are simulated by first solving the necessary CEM forward problems by an FEM with piecewise linear basis functions—on considerably denser meshes than the ones employed for the inverse solver—to obtain the “exact” potential vector $U^{\text{exact}} \in \mathbb{R}^Q$. Subsequently, the actual data are formed as

$$\mathcal{V} = U^{\text{exact}} + \eta,$$

where the components of $\eta \in \mathbb{R}^Q$ are independent realizations of a normally distributed random variable with zero mean and standard deviation

$$\tau = 10^{-3} \max_{j,k=1,\ldots,Q} |U_j^{\text{exact}} - U_k^{\text{exact}}|,$$

which corresponds to 0.1% of noise. The reconstruction algorithm is then applied to $\mathcal{V}$ with the regularization parameter $\lambda = 2\tau$. If (4.6) is interpreted as the determination

---

\(^2\)This initial guess corresponds to a disk of radius $\rho_0 = 17.5$, equiangled electrodes, a homogeneous conductivity $\sigma \equiv \sqrt{\varsigma_\sigma} \approx 0.32$, and contact resistances $z_m = \sqrt{\varsigma_z} \approx 0.22$, $m = 1, \ldots, 16$. 

Copyright © by SIAM. Unauthorized reproduction of this article is prohibited.
of a MAP estimate within the Bayesian paradigm, then $\lambda$ plays the role of the standard deviation for the assumed zero-mean Gaussian noise process with independent components (cf., e.g., [25]). In particular, we assume here twice as high a noise level as what is actually contaminating the (simulated) measurements.

The resulting conductivity reconstructions are illustrated in the right-hand column of Figure 2. They demonstrate that the algorithm is capable of capturing the qualitative behavior of the conductivity phantoms as well as the exterior boundary shapes of the examined objects. The circumference of the top left object in Figure 2 is approximately 121, while the circumference of its reconstruction is only 111. The corresponding values for the second object are 115 and 113, respectively. Thus, the reconstructed circumferences are close to that of $D(0)$, i.e., $2\pi \cdot 17.5 \approx 110$.

The reconstructed contact resistances and electrode angles are compared with the true ones in Figure 3; it is obvious that the algorithm does not estimate these quantities accurately. The inaccuracy demonstrated by Figure 3 is probably mainly due to the nontrivial interplay between the object shape, electrode angles, and contact resistances: Some features of the data caused by the object shape may be less “expensive” to explain by varying the electrode angles and/or contact resistances under the chosen regularization/prior model. Such behavior is most evident in the top right
Fig. 3. Simulated data. Left: The reconstructed electrode angles (red circles) compared with the true ones (blue asterisks). Right: The reconstructed contact resistances (red circles) compared with the true ones (blue asterisks). The top row corresponds to the top row of Figure 2, and the bottom row to the bottom row of Figure 2. (Color available online.)

image of Figure 3, where the too high values for the reconstructed contact resistances arguably compensate for the too small size of the reconstructed object in the top right image of Figure 2. It should also be noted that the orientation of the reconstruction in space is intimately connected to the reconstructed electrode angles: All (random) angle offsets for the target in the bottom left image of Figure 2 are negative, which leads to a reconstruction that is slightly rotated in the clockwise direction. This eliminates the systematic bias in the true electrode angles (in comparison to the parameter value \( y_E = 0 \)) and results in reconstructed angle offsets that take both positive and negative values.

To conclude this section, let us demonstrate what happens if the uncertainties related to the measurement geometry are simply ignored. Figure 4 shows the reconstructions of the target configurations in Figure 2 produced by our reconstruction algorithm when the premeasurement phase is computed in a disk of radius \( \rho_0 = 17.5 \) with equally spaced electrodes attached to its boundary. As illustrated by the extremely poor reconstructions of the conductivity in Figure 4, this naive approach is intolerable, which is in line with the findings of \([5, 8, 13, 14, 28]\). Moreover, the minimization algorithm converges slowly: As an example, the left image in Figure 4 required 121 function evaluations, whereas the top right image in Figure 2 was obtained with only 12 function evaluations, although the same (lsqnonlin’s default) stopping criterion was used.
5.2. Experimental data. We next apply our algorithm to four sets of experimental data from two water tanks: a thorax-shaped tank with circumference 106 cm and a deformable one with circumference 86 cm (cf. Figures 5 and 6). Both tanks have $M = 16$ rectangular metallic electrodes of width 2 cm attached to their interior lateral surface. In each experiment, the considered water tank contains vertically homogeneous embedded cylinders of steel and/or plastic extending from the bottom all the way through the water surface. The water level is controlled so that the tanks are always filled with tap water up to the top of the electrodes, which are of height 5 cm for the thorax-shaped tank and of height 7 cm for the deformable one. The measurements were performed with low-frequency (1 kHz) alternating current using the *Kuopio impedance tomography* (KIT4) device [29]. The phase information of the measurements is ignored, meaning that the amplitudes of electrode currents and potentials are interpreted as real numbers.

As the measurement configurations are vertically homogeneous and no current flows through the top or the bottom of the water layer, one can employ the two-dimensional version of the CEM as the forward model. For a discussion on the conversion of units between two and three spatial dimensions, see, e.g., [23]. In essence, if the voltage measurements on the electrodes are multiplied or, alternatively, the net currents are divided by the height of the tank, a two-dimensional inverse solver automatically produces reconstructions in the proper three-dimensional units. We take here the latter approach based on the (three-dimensional) current patterns (5.1); prior to the scaling by the tank height, the unit of current is mA. The regularization parameter is chosen as

$$
\lambda = 2 \cdot 10^{-3} \max_{j,k=1,\ldots,Q} |V_j - V_k|
$$

for both tanks. Loosely speaking, the Bayesian interpretation of this is that we expect roughly 0.1% of measurement noise as in the case of simulated data.

The conductivity reconstructions corresponding to the thorax-shaped tank are presented in Figure 5. The two target configurations are shown in the left-hand
column and the corresponding reconstructions on the right. In both cases, there are two cylinders placed inside the tank: a metallic one with square cross-section and a plastic one with round cross-section. For both targets, the reconstruction of the tank boundary is accurate in shape but not in size, and the approximate positions of the inclusions can also be deduced from the images in the right-hand column of Figure 5. However, especially the insulating inclusions appear blurred in the reconstructions, and there are also some oscillations in the estimated background conductivity level. Both reconstructions have a circumference of about 112 cm.

The reconstructions corresponding to the deformable tank are presented in Figure 6, which is organized in the same way as Figure 5: The target configurations are shown in the left-hand column and the associated reconstructions in the right-hand column. The water tank has been bent into two different shapes. (This time the target boundaries are not shown in the right-hand column since the exact shapes of the deformable tank are not known.) The corresponding conductivity phantoms consist of two pieces of plastic with rectangular cross-sections and of one round steel cylinder and a rectangular body of plastic, respectively. The reconstructions are not quite as informative as for the thorax-shaped tank, which is in line with our experience of expecting data from the deformable tank to be of lower quality. The shapes of
the reproduced exterior boundaries are clearly less accurate, the inclusions appear more blurred, and the variations in the background conductivity level are notable. It seems that the algorithm tries to explain some of the data variations originating from the inhomogeneities by deforming the object boundary. The reconstruction circumferences 116 cm (top) and 114 cm (bottom) are also quite far off the mark; our hypothesis is that the algorithm compensates for the overestimation of the tank size by downtuning the contact resistances (cf. the top right image of Figure 3). In any case, the reconstructions in Figure 6 still carry useful information about the corresponding targets. In particular, they are far better than those obtained by altogether ignoring the incompleteness of the information on the measurement geometry and computing the conductivity reconstruction in, e.g., a disk (cf. [14]): In Figure 7 we present the reconstructions similar to those in Figure 4. Now the geometry is fixed to a disk having the correct circumference of 86 cm and equiangled electrodes.

6. Conclusion. By employing cFEM, we have introduced a numerical algorithm that is capable of producing reasonable reconstructions of the conductivity by EIT in settings where the exterior boundary shape of the examined body is unknown. This conclusion was verified by numerical tests based on both simulated and experimental data. The algorithm consists of two stages: In the premeasurement processing, a polynomial surrogate model is formed for the CEM. This is the computationally expensive

![Figure 6](image-url)

**Fig. 6.** Experimental data from a deformable tank. Left: The target configurations. Right: The reconstructions. The unit of conductivity is mS/cm. The images are not to scale; the circumferences of the tank and the reconstructions are given in the text. (Color available online.)
part of the proposed method, but fortunately it can be carried out off-line prior to any actual measurements, assuming there is enough general-level information available on the measurement set-up (the approximate size and conductivity level of the body, the shape and number of the electrodes, etc.). The postmeasurement processing consists of minimizing a sum of squares of multivariate polynomials, which does not demand a lot of computation time—unless the polynomial order in the surrogate model is high. Our numerical experiments were based on second-degree polynomials and approximately a thousand parameters, which resulted in postprocessing times of only a few seconds.

**Acknowledgment.** We would like to thank Professor Jari Kaipio’s research group at the University of Eastern Finland (Kuopio) for granting us access to their EIT devices.

**REFERENCES**


